Docket No.:0756-7197

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)	
Koichiro TANAKA)	
Serial No. 10/664,916)	Group Art Unit: 1765
Filed: September 22, 2003)	Examiner: R. Kunemund
For: BEAM HOMOGENIZER AND LASER)	
IRRADIATION APPARATUS AND METHOD OF)	
MANUFACTURING SEMICONDUCTOR		
DEVICE		

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria VA 22313-1450, on 1.1, 25, 2005

SECOND REQUEST FOR STATUS

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the aboveidentified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

Eric J. Robinson

Reg. No. 38,285

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PMB 955

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